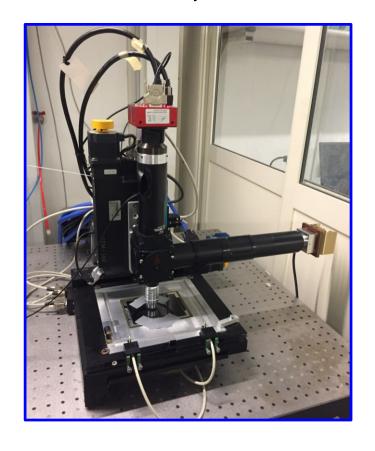
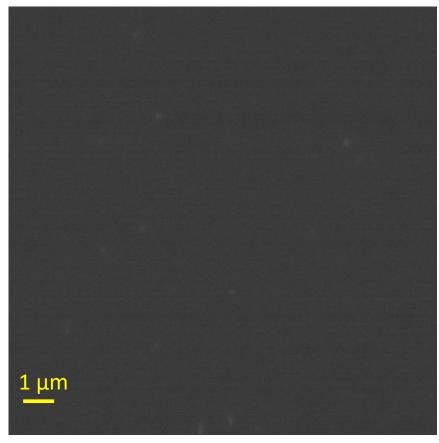
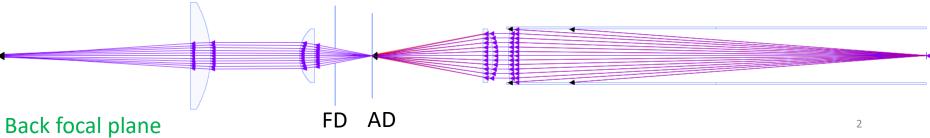
# New Illumination System Test

Andrey Alexandrov

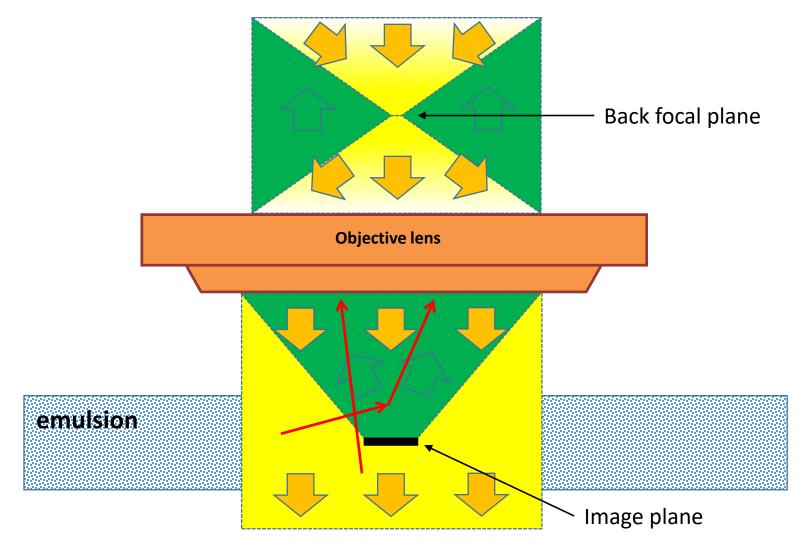
## Current production microscope



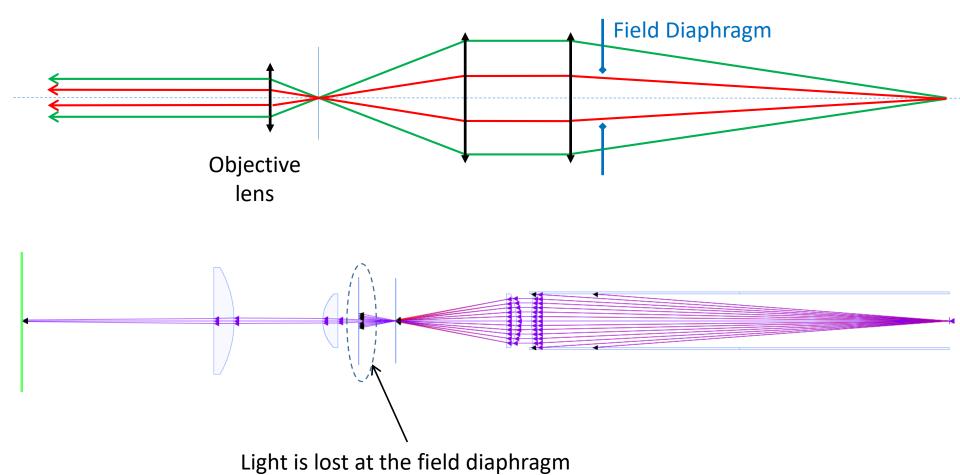




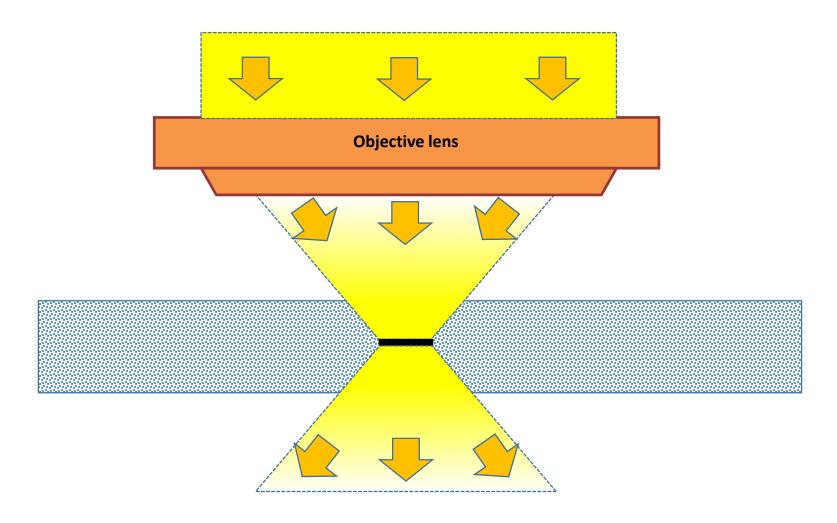
### Current illumination scheme



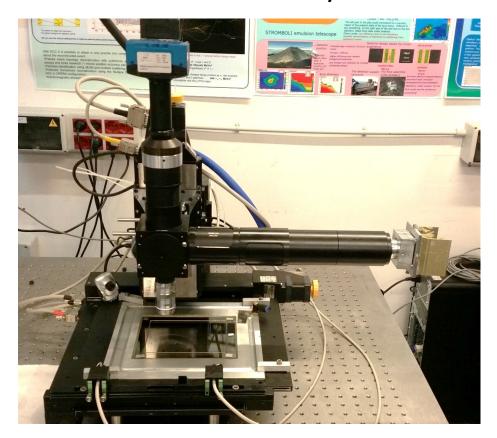
## Field Diaphragm

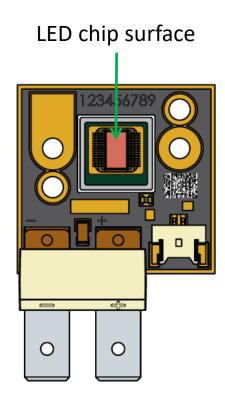


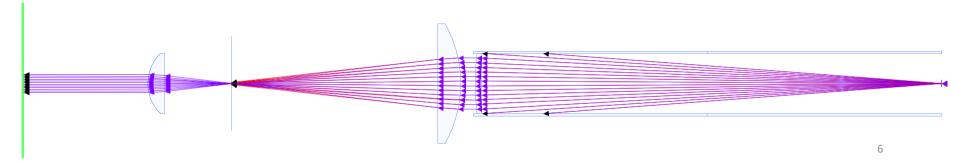
### New illumination scheme



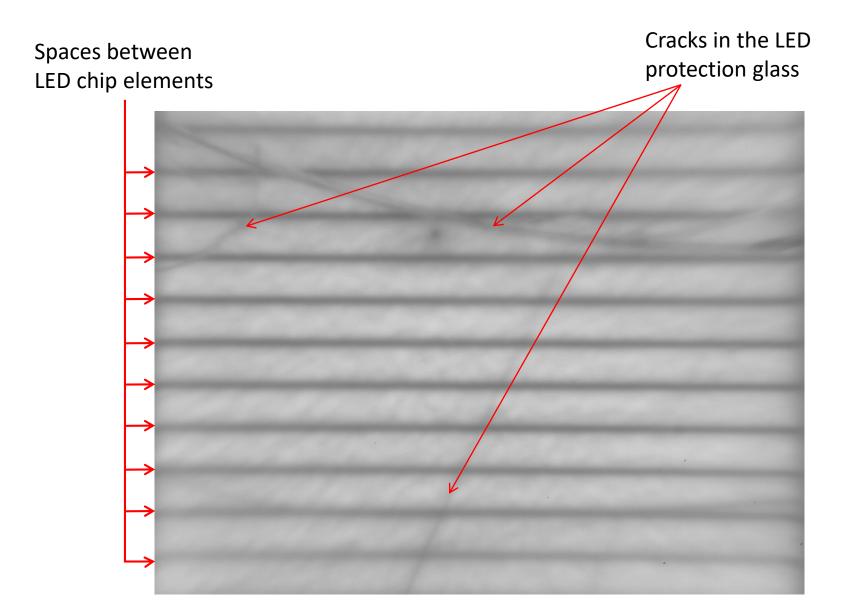
# New Illumination System



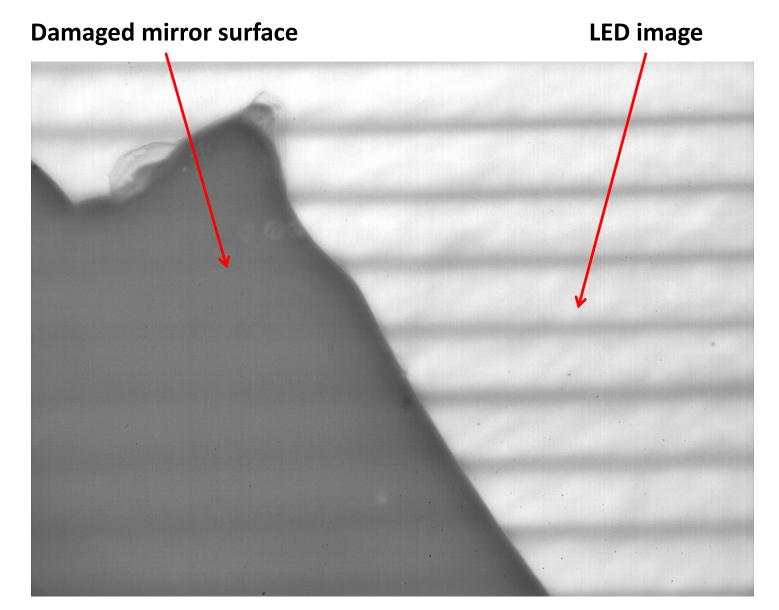




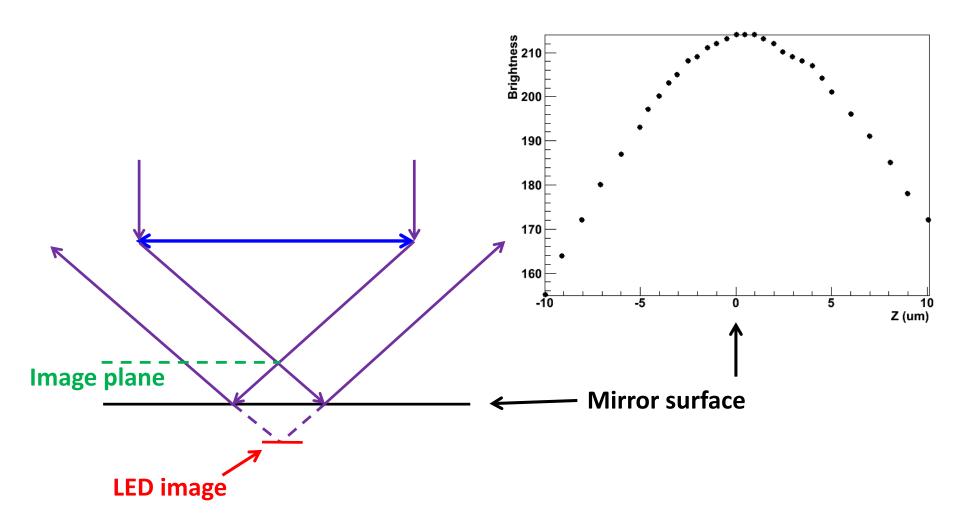
### LED source image



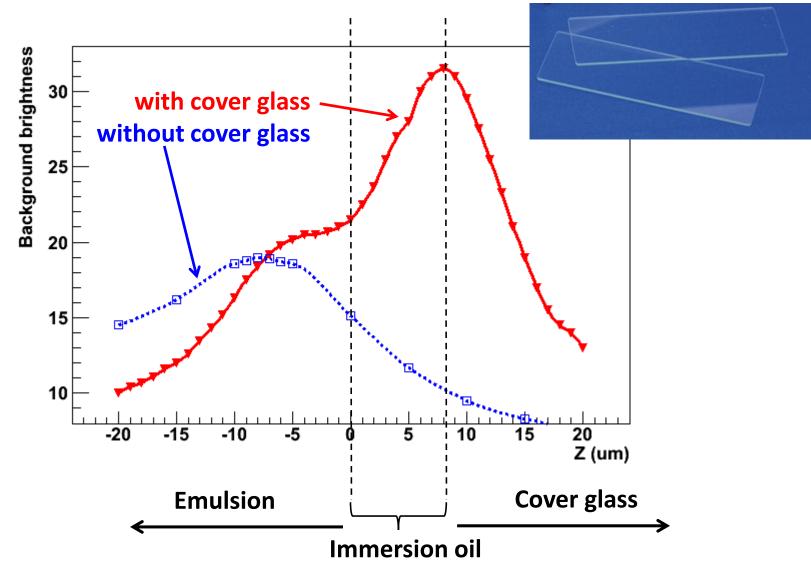
# Alignment with the camera



### Brightness dependency on depth



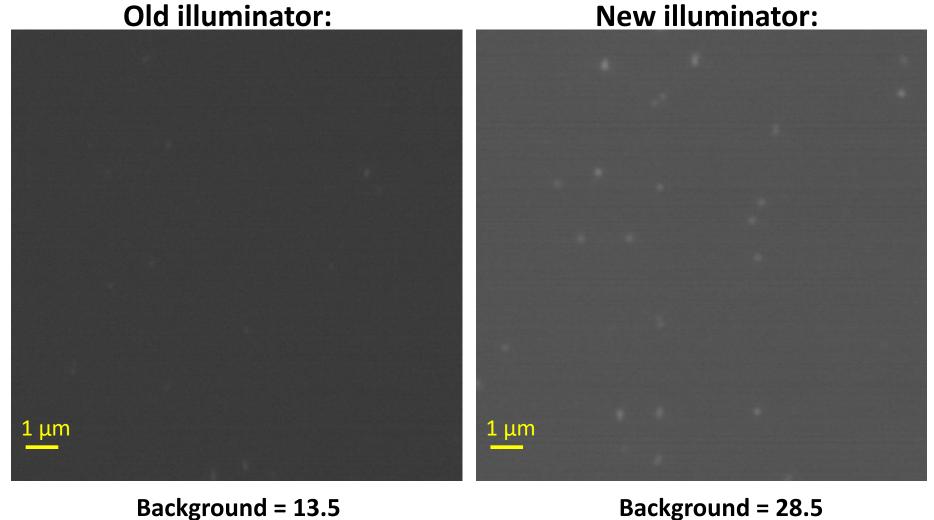
### Reflection from cover glass surface



# Optical resolution **Micrometer ticks**

Average resolution = 200 nm Resolution in the central region = 190 nm

### Test with 100keV C-ions

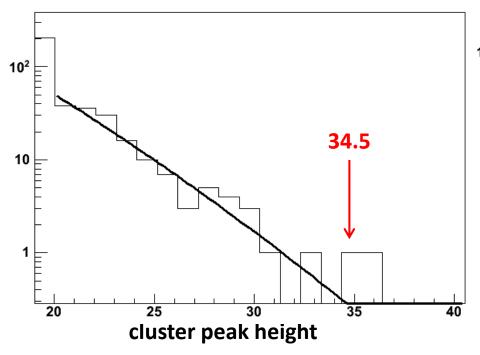


Noise level = 1.0

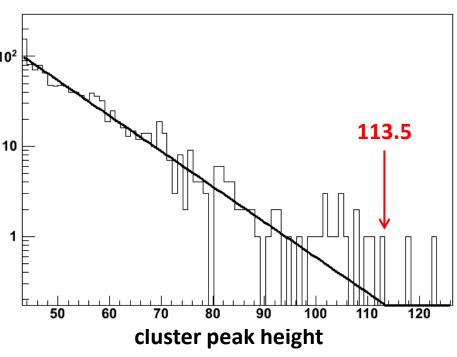
Background = 28.5 Noise level = 1.5

### Test with 100keV Carbon ions

### **Old illuminator:**



### **New illuminator:**



4x increase in the signal range 3x increase in the SNR

### Summary

- New illumination system was tested
- Optical resolution ~200 nm (190 in the center)
- Strong reflection from cover glass surface was observed
- 4x increase in the signal range was observed
- 3x gain in the SNR was observed

### Next steps:

- Test performance in automatic scanning
- Test performance with liquid crystal
- Assemble and test an achromatic version for white light